



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Koichiro KOMATSU et al.

Group Art Unit: 2877

Application No.: 09/481,503

Examiner: R. A. Rosenberger

Filed: January 12, 2000

Docket No.: 105173

For: SURFACE INSPECTION METHOD, SURFACE INSPECTION APPARATUS, AND
RECORDING MEDIUM AND DATA SIGNAL FOR PROVIDING SURFACE
INSPECTION PROGRAM

AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the March 8, 2002 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please amend the above-
identified application as follows:

IN THE CLAIMS:

Please replace claim 6 as follows:

6. (Amended) A surface inspection method according to claim 1, wherein:

Q 1 said plurality of inspection conditions are each set in conformance to an order
of diffracted light corresponding to a specific pitch of the pattern on the test piece.

REMARKS

Claims 1-12 are pending. By this Amendment, claim 6 is amended to correct a
typographical error. No new matter has been added. Reconsideration in view of the above
amendment and following remarks is respectfully requested. The attached Appendix includes
a marked-up copy of claim 6 (37 C.F.R. §1.121(c)(1)(ii)).